

FIG.-1



Sheet 2 of 2

Applicant: Uwe W. Hamm

Serial No.: 10/010,135

Title: Process and Device in-situ Decontamination
of an EUV-Lithography Device

Docket No.: FMW-SS

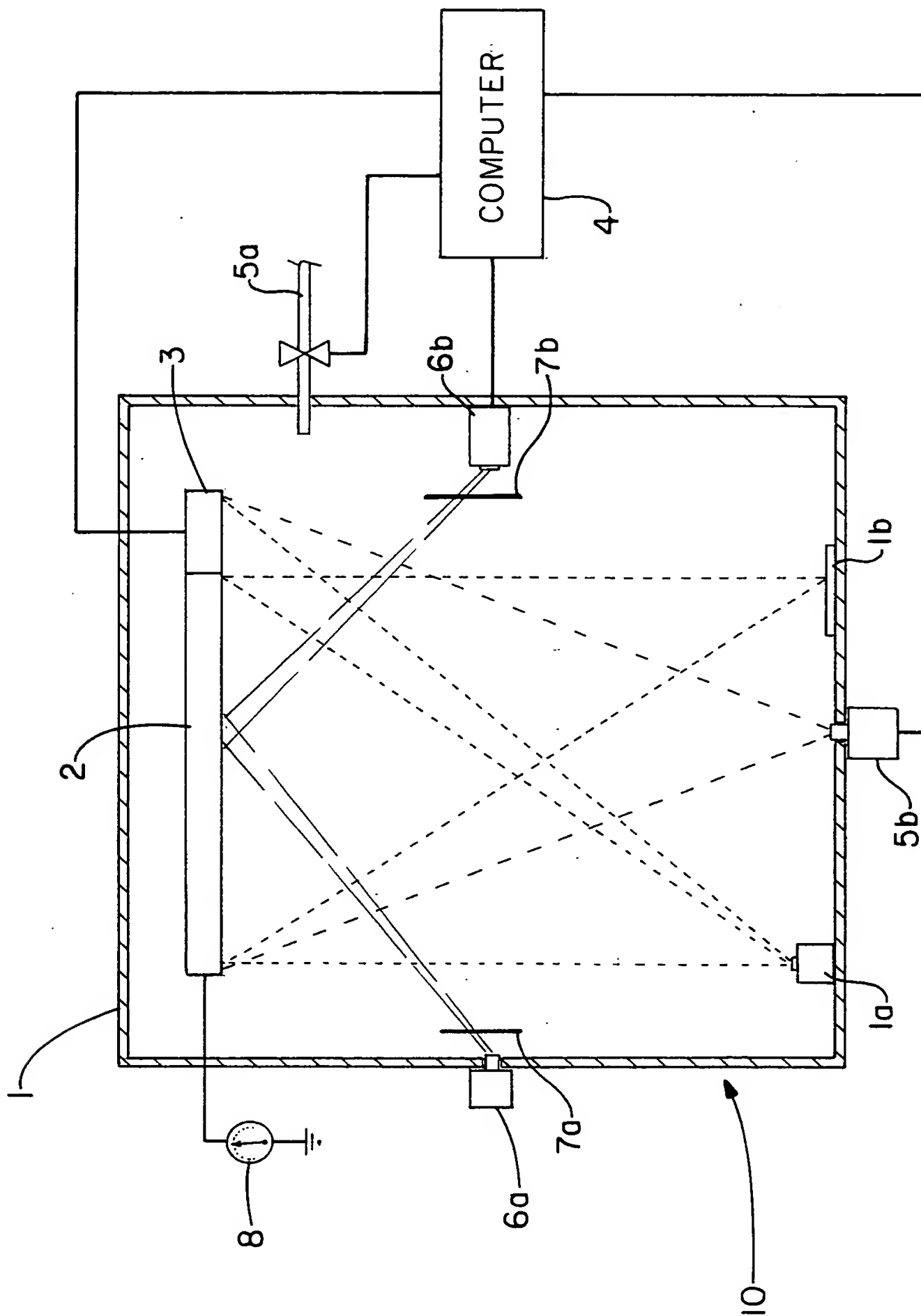


FIG.-2